

 PALM IntranetApplication
Number

IDS Flag Clearance for Application

 IDS
Information

Content	Mailroom Date	Entry Number	IDS Review	Reviewer
M844	07-29-2003	14	<input checked="" type="checkbox"/>	08-10-2005 22:35:27 IDS CONV

Refine Search

Search Results -

Terms	Documents
6313481	11

Database:

US Pre-Grant Publication Full-Text Database
US Patents Full-Text Database
US OCR Full-Text Database
EPO Abstracts Database
JPO Abstracts Database
Derwent World Patents Index
IBM Technical Disclosure Bulletins

Search:

L13

Refine Search

Recall Text

Clear

Interrupt

Search History

DATE: Tuesday, March 07, 2006 [Printable Copy](#) [Create Case](#)

<u>Set Name</u>	<u>Query</u>	<u>Hit Count</u>	<u>Set Name</u>
side by side			result set

DB=USPT; PLUR=YES; OP=OR

<u>L13</u>	6313481	11	<u>L13</u>
<u>L12</u>	6303483	13	<u>L12</u>
<u>L11</u>	6088070	20	<u>L11</u>
<u>L10</u>	5923962	281	<u>L10</u>
<u>L9</u>	5923962	281	<u>L9</u>
<u>L8</u>	5923963	18	<u>L8</u>
<u>L7</u>	5913100	4	<u>L7</u>
<u>L6</u>	5738948	4	<u>L6</u>
<u>L5</u>	5738948L4	0	<u>L5</u>
<u>L4</u>	5643826	466	<u>L4</u>
<u>L3</u>	5594569	140	<u>L3</u>
<u>L2</u>	6,281,057	6	<u>L2</u>
<u>L1</u>	5,504,020	28	<u>L1</u>

Refine Search

Search Results -

Terms	Documents
5504020 and (tungsten)	10

Database:

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Search:

L13	<input type="button" value="Up"/> <input checked="" type="checkbox"/>	<input type="button" value="Refine Search"/>
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Search History

DATE: Tuesday, March 07, 2006 [Printable Copy](#) [Create Case](#)

Set Name **Query**
side by side

Hit Count **Set Name**
result set

DB=USPT; PLUR=YES; OP=OR

L13 5504020 and (tungsten)

10 L13

DB=PGPB; PLUR=YES; OP=OR

L12 L11 and (gate and tungsten)

37 L12

L11 ((gate near4 resist) near10 (mask near5 impurit\$5))

85 L11

DB=USPT; PLUR=YES; OP=OR

L10 L9 and ((gate near4 resist) near10 (mask near5 impurit\$5))

19 L10

L9 L6 and (gate near10 tungsten)

148 L9

L8 L6 and (gate near5 tungsten)

86 L8

L7 L6 and (gate and tungsten)

462 L7

L6 L2 and method

1020 L6

L5 L2 andd method

2309983 L5

L4 L2 andd method

2309983 L4

L3 L2 andd method

2309983 L3

L2 (ion or impurity) same ((gate near7 resist) near5 mask)

1043 L2

L1 (ion or impurity) same ((gate near7 resist) near10 mask) 1139 L1

END OF SEARCH HISTORY